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Packet No.: 050212-0569

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of : Customer Number: 20277
Manabu SHIOZAKI, et al. : Confirmation Number: 6260
Application No.: 10/764,497 : Group Art Unit: 2872
Filed: January 27, 2004 : Allowed: August 15, 2005
Examiner: Fayez G. Assaf

For: DIFFRACTION GRATING ELEMENT, PRODUCTION METHOD OF
DIFFRACTION GRATING ELEMENT, AND METHOD OF DESIGNING
DIFFRACTION GRATING ELEMENT

**REQUEST FOR ACKNOWLEDGEMENT OF THE CITED ART
AND REVISED FORM PTO-1449**

Mail Stop ISSUE FEE
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Applicants are in receipt of the Notice of Allowance dated August 15, 2005.

In reviewing the file, it is noted that we have received only a partial
acknowledgement of the Information Disclosure Statement and cited art filed August 11,
2004. The Examiner did not consider the last 2 articles listed on Form PTO-1449 (copy
enclosed) because the information identifying these articles did not comply with 37 CFR
1.98(b); namely, the author, title and place of publication was missing.

Enclosed is a corrected copy of PTO-1449 which includes all the information. It
is believed that no fees are necessary since applicants are merely inserting the
information on the 1449 which was contained in the references previously submitted.

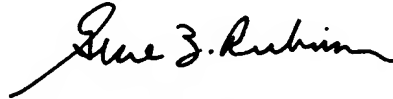
No.: 10/764,497

Applicants hereby respectfully request that:

- (1) the appropriately acknowledged PTO-1449 be furnished to Applicants;
- and
- (2) the record be clarified to confirm that the cited art has been considered and made of record.

Respectfully submitted,

McDERMOTT WILL & EMERY LLP



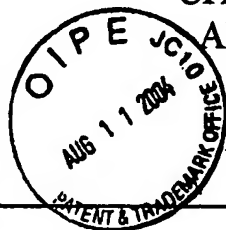
Gene Z. Robinson
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Phone: 202.756.8000 GZR:cg
Facsimile: 202.756.8087
Date: August 26, 2005

**Please recognize our Customer No. 20277
as our correspondence address.**



SHEET 1 OF 1

INFORMATION DISCLOSURE
CITATION IN AN
APPLICATION

(PTO-1449)

ATTY. DOCKET NO.
50212-569SERIAL NO.
10764,497APPLICANT
Manabu SHIOZAKI, et al.FILING DATE
January 27, 2004GROUP
Not yet assigned

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U.S. PATENT DOCUMENTS

EXAMINER'S INITIALS	CITE NO.	Document Number Number-Kind Codes (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		US			
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FOREIGN PATENT DOCUMENTS

EXAMINER'S INITIALS	CITE NO.	Foreign Patent Document Country Codes-Number & Kind Codes (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines Where Relevant Figures Appear	Translation	
						Yes	No

OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)

EXAMINER'S INITIALS	CITE NO.	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.
FA		KASHIKO KODATE; "Development of Diffractive Optics and Future Challenges"; <u>Japan Women's Bulletin</u> , Department of Mathematical and Physical Sciences, Vol. 10; c. 2002; pp. 7-24
RA		HENDRIK J. GERRITSEN et al.; "Rectangular Surface-Relief Transmission Gratings with a Very Large First-Order Diffraction Efficiency (~95%) for Unpolarized Light"; <u>Applied Optics</u> ; Vol. 37, No. 25; c. 1998; pp. 5823 - 5829
		Summary of Workshop on Nanotech Material Associated with Devices, c. 2002; pp. 125 - 127
		Nanotech Weekly, Vol. 1133, c. 2003; pp. 6-21

EXAMINER

FAYEZ ASAT

DATE CONSIDERED

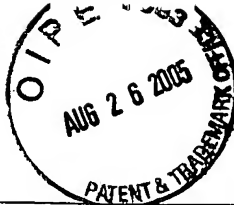
8/9/05

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

1 Applicant's unique citation designation number (optional). 2 Applicant is to place a check mark here if English language Translation is attached.

*: incomplete information: Author, title, place of publication.

see 37 CFR 1.98(b)



SHEET 1 OF 1

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		US			
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						Yes	No

OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)

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		KASHIKO KODATE; "Development of Diffractive Optics and Future Challenges"; <u>Japan Women's Bulletin</u> , Department of Mathematical and Physical Sciences, Vol. 10; c. 2002; pp. 7-24
		HENDRIK J. GERRITSEN et al.; "Rectangular Surface-Relief Transmission Gratings with a Very Large First-Order Diffraction Efficiency (~95%) for Unpolarized Light"; <u>Applied Optics</u> ; Vol. 37, No. 25; c. 1998; pp. 5823 - 5829
		SHUHEI TANAKA, Lecture entitled: "Glass Materials for Optical Waveguiding Nanoglass Devices", Summary of Workshop on Nanotech-Material Associated With Devices, 2002, pp 125-127, Japan.
		TATSUYA HORII, "Epoch of Light Caused By Nano Glass" <u>Nanotech Weekly</u> , Vol. 1133, pp 6-21, 2003, Japan

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